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PTO/SB/122 (09-04)

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Application Number	See attached schedule
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First Named Inventor	
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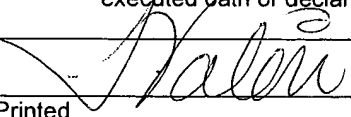
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- ☒ Attorney or agent of record. Registration Number 41,417
- ☐ Registered practitioner named in the application transmittal letter in an application without an executed oath or declaration. See 37 CFR 1.33(a)(1). Registration Number \_\_\_\_\_

Signature 

Typed or Printed Name Tamsen Valoir, Ph.D.

Date 4.13.2005	Telephone 713.427.5007
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NOTE: Signatures of all the inventors or assignees of record of the entire interest or their representative(s) are required. Submit multiple forms if more than one signature is required, see below\*.

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SCHEDULE A - PATENTS AND PATENT APPLICATIONS (S T M icroelectronics)								
Docket No.	Title of Invention	Appl. No.	File Date	Patent No.	Issue Date	Reel/Frame No.		
31175803-003001	Method and Device for Confining Live Neural Cells Cultivated on a Chip of Noninvasive Neuroelectronic Interfacing	11/040080	1/21/2005			n/a		
31175803-004002	Apparatus for Biochemical Analysis	11/092415	3/29/2005			n/a		
31175803-004001	Integrated Device for Biological Analyses	10/663286	9/16/2003			015030/0589		
31175803-005001	Micropump for Integrated Device for Biological Analyses	10/663239	9/16/2003			014978/0331		
31175803-006001	Integrated Device for Microfluid Thermoregulation, and Manufacturing Process Thereof	09/779980	2/8/2001	6673593	1/6/2004	011766/0716		
31175803-006002	Integrated Device for Amplification and Other Biological Tests, and Manufacturing Process Thereof	10/706246	11/12/2003			011766/0716		
31175803-007001	Process for Manufacturing Integrated Chemical Microreactors of Semiconductor Material	09/874382	6/4/2001	6710311	3/23/2004	014105/0698		

31175803-007002	Process for Manufacturing Integrated Chemical Microreactors of Semiconductor Material	10/784509	2/23/2004			014105/0698
31175803-008001	Integrated Device Based Upon Semiconductor Technology, in Particular Chemical Microreactor	10/128989	4/22/2002	6727479	4/27/2004	014813/0881 014485/0695
31175803-008002	Integrated Device Based Upon Semiconductor Technology, in Particular Chemical Microreactor	10/795589	3/8/2004			014813/0881 014485/0695
31175803-009002	Integrated Chemical Microreactor, Thermally Insulated from Detection Electrodes, and Manufacturing and Operating Methods Therefor	10/874902	6/23/2004			012566/0773
31175803-009003	Integrated Chemical Microreactor, Thermally Insulated from Detection Electrodes, and Manufacturing and Operating Methods Therefor	10/874905	6/23/2004			012566/0773
31175803-009001	Integrated Chemical Microreactor, Thermally Insulated from Detection Electrodes, and Manufacturing and Operating Methods Therefor	09/965128	9/26/2001	6770471	8/3/2004	012566/0773
31175803-011001	Integrated Chemical Microreactor with Large Area Channels and Manufacturing Process Thereof	10/996593	11/24/2004			n/a

31175803-012001	Integrated Chemical Microreactor with Separated Channels for Confining Liquids Inside the Channels and Manufacturing Process Thereof	10/997235	11/24/2004			pending
31175803-013001	Integrated Semiconductor Microreactor for Real-Time Monitoring of Biological Reactions	11/009171	12/10/2004			pending
31175803-014001	Microfluidic Device and Method for Transporting Electrically Charged Substances Through a Microchannel of a Microfluidic Device	11/017272	12/20/2004			pending
31175803-015001	Microfluidic Device and Method of Locally Concentrating Electrically Charged Substances in a Microfluidic Device	11/015633	12/17/2004			pending